



Attorney's Docket No.: 042390.P4220

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Bohr, Mark T.

U.S. Serial No: 09/002,178

Filed: December 31, 1997

For: WAFER PASSIVATION  
STRUCTURE AND METHOD OF  
FABRICATION

Examiner: Guerrero, Maria

Art Unit: 2822

Assistant Commissioner for Patents  
Washington, D.C. 20231

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17/1 Rey,  
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Response  
G. Stanley  
10-10-01

PRELIMINARY AMENDMENT

Dear Sir:

Please enter the enclosed Preliminary Amendment and consider the following remarks prior to examination of the above-referenced case.

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FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

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